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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

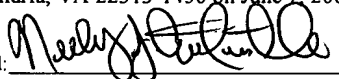
Application No. : 09/611,037
Applicant: : Kuthi, et al.
Filed: : July 6, 2000
Title: : METHOD FOR IMPLEMENTING A
SEMICONDUCTOR PROCESS CHAMBER
ELECTRODE

TC/A.U. : 1763
Examiner : Alejandro Mulero, L.

Atty. Docket No. : LAM1P077A
Date: : June 7, 2004

☐ **Duplicate for
fee processing**

Commissioner for Patents
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING
I hereby certify that this correspondence is being deposited
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an envelope addressed to: Commissioner for Patents, P.O.
Box 1450, Alexandria, VA 22313-1450 on June 7, 2004.
Signed: 
Neely J. Entwistle


Sir:

Transmitted herewith is an amendment in the above-identified application.
The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	16 -	20	0	X09 = \$	OR	X18 = \$0
INDEP CLAIMS	03 -	03	0	X40 = \$	OR	X80 = \$0
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$135		\$270
			TOTAL	\$_____		\$_____

- ☒ Applicant believes that no Extension of Time is required; however, if it is determined that such an extension is required, Applicant hereby petitions that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805
- ☒ If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM1P077A). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE & PENILLA, LLP


Rick von Wohld, Esq.
Reg. No. 48,018

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Sunnyvale, CA 94085
Telephone: (408) 749-6900
Customer Number 25920



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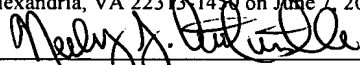
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AMENDMENT

Sir:

Applicants submit this paper in response to the Notice of Non-Compliant Amendment dated May 20, 2004. The period for response extends to June 20, 2004. Please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Argument begins on page 8 of this paper.